

<b>Notice of References Cited</b>	Application/Control No. 10/653,754	Applicant(s)/Patent Under Reexamination MEIER ET AL.	
	Examiner Daniel Kim	Art Unit 2185	Page 1 of 1

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*	B	US-2002/0188806	12-2002	Rakvic et al.	711/119
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NON-PATENT DOCUMENTS

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